New Opportunities in Two-dimensional Materials

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A Brief History of Materials

The Stone Age



The Bronze Age



The Iron Age



The Silicon Age?







"Interface is the Device"



The first transistor, Bell Lab, 1947

Graphene: The Beginning of 2D Material Research



Geim group (2004)

Graphene : Dirac Fermions in 2D



P. R. Wallace, *Phys. Rev.* 71, 622 (1947).T. Ando et al, *J. Phys. Soc. Jpn* 67, 2857 (1998).

 $E = \hbar k v_F$ E = pc





Less is different

Families of New Materials in 2D



Hundreds of 2D crystals waiting to be explored

Opportunities to Tune the Material Properties in 2D



New device paradigm?



Black phosphorus (semiconductor)

- \Box 1T-TaS₂ (metal)
 - Gate-controlled intercalation
 - □ Tunable Phase in 1T-TaS₂

Allotropes of Phosphorus





White Phosphorus





Red Phosphorus





Allotropes of Phosphorus: Black Phosphorus

Black Phosphorus





TWO NEW MODIFICATIONS OF PHOSPHORUS.

By P. W. BRIDGMAN. Received May 4, 1914.

The two new modifications of phosphorus to be described here were obtained during an investigation of the effect of high pressure on the melting point of ordinary white phosphorus. The two new forms have perfectly distinct characteristics; in this they are different from the questionable modifications of red phosphorus often announced. The first of these modifications is a new form of white phosphorus, which changes

Layered crystal structure



Review: Morita, *Applied Physics A* **39**, 227–242 (1986).

Phosphorene v.s. Graphene



Graphene

- Planar honey-comb lattice
- **4** valence electrons
- Half-filled conduction band
- Zero-gap semiconductor

Phosphorene

- Puckered honey-comb lattice
- **5** valence electrons
- **Fully filled** valence band
- **Gapped** semiconductor

Phosphorene v.s. Graphene

Phosphorene

Graphene



Y. Takao, et al., *J. Phys. Soc. Jpn.* 50, 3362 (1981)

P. R. Wallace, Phys. Rev. 71, 622 (1947).

Thickness-dependent Bandgap in few-layer Phosphorene

Band structure of the bulk

Direct band gap ~ 0.3 eV



Thickness-dependent bandgap



Direct bandgap tunable by varying thickness

Thickness-dependent Band Gap

Bridging the gap



Churchill and Jarillo-Herrero, Nature Nano. (2014)

Black Phosphorus Field-effect Transistor







Likai Li

Fangyuan Yang

Likai Li *et al.* Nature Nano. **9**, 372 (2014).

See also:

Liu, H. et al. ACS Nano 8, 4033 (2014). Koenig, S. P. et al., APL 104, 103106 (2014). Xia, F. et al., Nature Comm. 5, 4458 (2014).

Highest on-off ratio $\sim 10^5$



Limiting Factors of Carrier Mobility

Before

After



Sample left in air for 3 days

Black Phosphorus on Hexagonal Boron Nitride

Optic Image of Black Phosphorus on BN

Cross-sectional View





Protecting the bottom surface with hBN

Quantum Oscillations in Black Phosphorus on hBN

B = 31T, T = 0.3K



2D Electron and Hole Gases in Black Phosphorus



2D Electron and Hole Gases in Black Phosphorus



2D electron and hole gases are confined to ~ 2 atomic layers

2D Electron and Hole Gases in Black Phosphorus



Crucial information obtained from the quantum oscillations Likai Li *et al.* Nature Nano., Advance Online Publication (arXiv:1411.6572).

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See also:
Tayari, V. et al., arXiv:1412.0259 (2014).
Chen, X. et al., arXiv:1412.1357 (2014).
Gillgren, N. et al., 2D Mater. 2, 011001 (2015).
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Even Higher Mobility?

Top View

Side View



Graphite local gate screens impurity potential, leads to high mobility

High Mobility Black Phosphorus 2DEG



Factor of 3 increase in mobility

Quantum Hall Effect in Black Phosphorus 2DEG



Likai Li et al. arXiv:1504.07155 (2015)

Landau Level Energy Landscape





Anyons in Black Phosphorus 2DEG?

Even-denominator fractional quantum Hall states in ZnO



Black phosphorus potentially harbors similar FQH states

1T-TaS₂: a Strongly Correlated 2D Material

Crystal structure of 1T-TaS₂



Yijun Yu



Various CDW Phases in 1T-TaS₂



Various CDW Phases in 1T-TaS₂

Commensurate CDW and Mott Insulator State



Wilson et al., *Adv. Phys.* (1975) Fazekas, P. & Tosatti, E. *Philos. Mag. B* (1979) Sipos, *et al. Nat. Mater.* (2008).

Gate Doping Limits

Conventional Dielectric Gating

Gate + + + + + + SiO₂ Ion Liquid Gating



Maximum n ~ 10¹³ cm⁻²

Maximum n ~ 10¹⁴-10¹⁵ cm⁻² Only top atomic layer

K.Ueno, Nat. Mater. (2008); D.K.Efetov, Phys. Rev. Lett. (2010); J.T.Ye, Nat. Mater. (2010); J.G.Checkelsky, Nat. Phys. (2012); Nakano, Nature (2012); J.T.Ye, Science (2013)

Tuning TaS₂ through Gate-controlled intercalation

Gate-controlled intercalation in TaS₂



 $n \sim 10^{15} \text{ cm}^{-2}$ for EACH atomic layer

Device Structure



Yijun Yu et al. Nature Nano., 10, 270 (2015).

1T-TaS₂ Ionic Field-effect Transistors (iFET)



iFET operates through ion diffusion















Electron Doping from Charge Transfer



~ 20% electron doping from charge transfer from Li

Tunable Phases in 1T-TaS₂ iFET



Intercalation Compared with Pressure and Isovalent Substitution







Tunable Phases in 1T-TaS₂



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